

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	Docket No: Q110157
Akira NAKAGAWARA, et al.	Allowed: July 28, 2009
Appln. No.: 10/570,346	Group Art Unit: 1649
Confirmation No.: 1857	Examiner: MACFARLANE, STACEY NEE
Filed: June 6, 2006	Issued: December 1, 2009
U.S. Patent No.: 7,625,711	

For: SCREENING METHOD FOR COMPOUNDS THAT INHIBIT THE INTERACTION
BETWEEN AICD AND P53

SUBMISSION OF REFERENCES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is requested that the documents listed below (copies enclosed, except for U.S. patents and/or publications) be placed in the U.S. Patent and Trademark Office's file wrapper of the above-identified U.S. patent:

1. Japanese Published Patent Application No. JP-A-2001-503988, with English-language Abstract.
2. U.S. Patent Application Publication No. 2003-0158117.
3. Japanese Office Action issued in corresponding JP Application No. 2005-513698, dated November 16, 2010.

Applicants note that WO 02/07950, the Park et al. article, the Araki et al. article, and the Kinoshita et al. article cited in the Office Action issued in the corresponding Japanese patent application were previously submitted in the above-identified application.

The undersigned has not reviewed the teachings of the above-listed document in detail and thus makes no representations concerning the relevancy or materiality of the above-listed document.

This is not an Information Disclosure Statement and no response from the U.S. Patent and Trademark Office is believed to be necessary, nor are any fees believed to be due.

Respectfully submitted,

/Sunhee Lee/

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WASHINGTON OFFICE

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